



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yasuhiro SHIMADA et al.

Application No.: 09/819,906

Filed: March 29, 2001

For: ELECTRON OPTICAL SYSTEM ARRAY,
METHOD OF MANUFACTURING THE
SAME, CHARGED-PARTICLE BEAM
EXPOSURE APPARATUS, AND DEVICE
MANUFACTURING METHOD

Examiner: K.T. Nguyen
Group Art Unit: 2881
Confirmation No.: 5368
Allowed: July 11, 2003
October 14, 2003
(Tuesday After Holiday)

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Preliminary Amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below:

°Verified Statement claiming small entity status is enclosed, if not filed previously.

A check in the amount of \$1,032.00 is enclosed including the RCE filing fee (\$770.00) and the fees for additional claims (\$262.00).

Charge \$____ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.

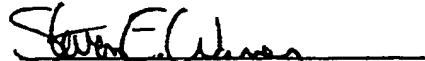
Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.

A check in the amount of \$____ to cover the fee for a _____ month extension is enclosed.

A check in the amount of \$____ to cover the Information Disclosure Statement fee is enclosed.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Steven E. Warner
Registration No. 33,326

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SEW/eab

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PATENT APPLICATION

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PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application
as follows:

10/17/2003 MAILED1 0000042 09819906

02 FC:1201
03 FC:1202

172.00 0P
90.00 0P

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Match and Return